

# Notice of Allowability

Application No.

09/748,965

Examiner

Karla Moore

Applicant(s)

CANTELL ET AL.

Art Unit

1763

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. ☒ This communication is responsive to 2/12/04.
2. ☒ The allowed claim(s) is/are 10,13-21 and 23-29.
3. ☒ The drawings filed on 27 December 2000 are accepted by the Examiner.
4. ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
  - a) ☐ All b) ☐ Some\* c) ☐ None of the:
    1. ☐ Certified copies of the priority documents have been received.
    2. ☐ Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.
    3. ☐ Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

\* Certified copies not received: \_\_\_\_\_.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  
**THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.**

5. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
6. ☐ CORRECTED DRAWINGS (as "replacement sheets") must be submitted.
  - (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached
    - 1) ☐ hereto or 2) ☐ to Paper No./Mail Date \_\_\_\_\_.
  - (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date \_\_\_\_\_.

Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
7. ☐ DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

## Attachment(s)

1. ☒ Notice of References Cited (PTO-892)
2. ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08), Paper No./Mail Date \_\_\_\_\_
4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material
5. ☐ Notice of Informal Patent Application (PTO-152)
6. ☐ Interview Summary (PTO-413), Paper No./Mail Date \_\_\_\_\_
7. ☐ Examiner's Amendment/Comment
8. ☒ Examiner's Statement of Reasons for Allowance
9. ☐ Other \_\_\_\_\_

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## DETAILED ACTION

### *Allowable Subject Matter*

1. Claims 10, 13-21 and 23-29 are allowed.
2. The following is an examiner's statement of reasons for allowance: The prior art of record fails to fairly teach or suggest: a system capable of forming a silicide on a surface of a semiconductor substrate comprising: a mainframe comprising at least **an interior cleaning chamber under a continuous vacuum and at least an interior deposition chamber under continuous vacuum; at least one pump adapted to evacuate said mainframe to maintain said continuous vacuum in said mainframe such that said continuous vacuum comprises a *constant* vacuum throughout said mainframe and each of said interior cleaning chamber and said interior deposition chamber during processing;** a chemical agent input into said interior cleaning chamber within said mainframe; a reactor in said deposition chamber with said mainframe; and a heating element. Specifically, the prior art fails to teach or fairly suggest a mainframe under continuous and constant (non-varying pressure); the mainframe capable of also maintaining an interior deposition chamber and an interior cleaning chamber under continuous and constant vacuum, as well.
3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

### *Conclusion*

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Nishida et al. teaches the use of a vacuum mainframe chamber housing two vacuum interior chambers. However, during processing the vacuum created in each of the interior chambers is established in an entirely isolated manner from the vacuum created in the mainframe. Thus, the vacuum is not constant and continuous throughout the mainframe and each of the interior chambers. Lee teaches the benefits and advantages of providing a double buffer vacuum system, but is silent on whether or not or how the

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apparatus could be adapted to accommodate additional interior chambers. Clarke discloses a vacuum mainframe with interior vacuum chambers, but is silent on the connectivity of the mainframe with the interior chambers (i.e. whether or not they are capable of being held at a continuous and constant vacuum). Arena et al. disclose a mainframe chamber with interior processing chambers but the apparatus is not taught as an apparatus for vacuum processes.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Karla Moore whose telephone number is 571.272.1440. The examiner can normally be reached on Monday-Friday, 8:30am-5:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory Mills can be reached on 571.272.1439. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

km  
30 April 2004

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Primary Examiner  
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